



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Densen Cao Examiner: Ralph A. Lewis

Serial Number: 10/017,454 Group Art Unit: 3732

Filed: December 13, 2001

For: "Improved Semiconductor Curing Light System Useful for Curing Light Activated

Composite Materials"

DOCKET: 5061 P

#### Response and Submission of New Drawings

Mail Stop: ISSUE FEE Commissioner for Patents P. O. Box 1450 Alexandria, Virginia 22313-1450

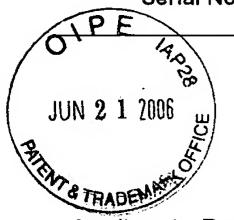
Honorable Commissioner:

This paper is a response to the communication from the Office dated May 17, 2006 concerning drawings. This paper is intended to be fully responsive to that communication.

### **DRAWINGS**

Please replace the drawings in the case with the new drawings that are attached. Figures 33d, 34c and 34d were not in the original drawing submission and are not intended to be included in the case.

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# **CERTIFICATE OF MAILING**

Mail Stop: ISSUE FEE
Commissioner for Patents
P. O. Box 1450
Alexandria, Virginia 22313-1450

#### Honorable Commissioner:

I hereby certify that the attached Response and Submission of New Drawings is being submitted via First Class Mail with the United States Postal Service in an envelope with sufficient postage addressed to: "Mail Stop: ISSUE FEE, Commissioner for Patents, P. O. Box 1450, Alexandria, Virginia 22313-1450" on this 19<sup>th</sup> day of June, 2006.

Respectfully submitted this 19<sup>th</sup> day of June, 2006.

Danie Mr. McCarthy

Reg. No. 36,600

PARSONS, BEHLE & LATIMER 201 South Main Street, Suite 1800

Salt Lake City, Utah 84111

(801) 532-1234